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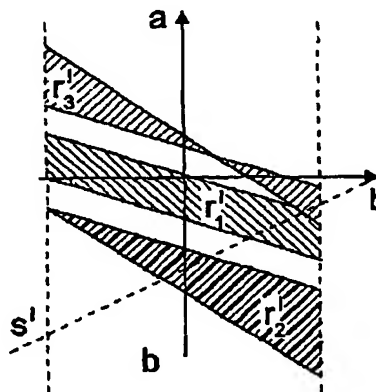
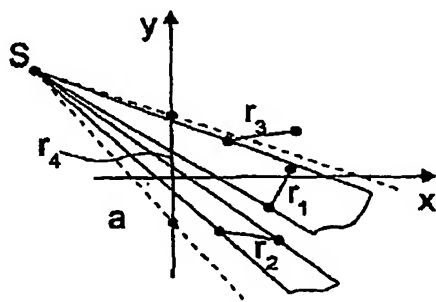
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[Continued on next page]

(54) Title: METHOD FOR DETERMINING REFLECTIONS IN AN AREA.



(57) Abstract: The present invention refers to a method for determining reflections in complex environments, by means of ray tracing. For ray tracing it is necessary to determine the region of visibility between at least a first reflector and a second reflector by means of the following phases: representing said first and second reflector in a system of coordinates (x, y, z); said method is characterised in that it further comprises the phases of: carrying out an affine transformation of said system of coordinates (x, y, z); determining the region of visibility of said second reflector in relation to said first reflector as the set of the parameters of the straight lines that link a generic point of said first reflector with a generic point of said second reflector.

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